



00862.022516.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryo TAKAI et al.

Application No.: 10/073,593

Filed: February 12, 2002

For: EXPOSURE APPARATUS INCLUDING
INTERFEROMETER SYSTEM

)
: Examiner: M. Lyons
)
: Group Art Unit: 2877
)
: Confirmation No. 4328
)
:
) October 16, 2003
:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR APPROVAL OF DRAWINGS CHANGE

Sir:

With the Examiner's approval, and at such time as a Notice of Allowance may issue, Applicants propose to amend the drawings in the above-identified application as follows:

In Fig. 13, add a label "PRIOR ART" as indicated.

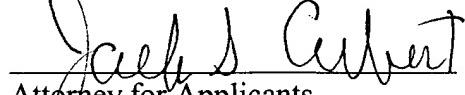
In Fig. 14, add a label "PRIOR ART" as indicated.

In Fig. 15, add a label "PRIOR ART" as indicated.

The proposed changes are indicated marked in red on the enclosed duplicate copies of the pertinent figures as filed.

Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,



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